

IIT MADRAS Indian Institute of Technology Madras



Industrial Consultancy & Sponsored Research (IC&SR)

METHOD FOR SIMULATION ASSISTED DATA GENERATION AND DEEP LEARNING INTELLIGENCE CREATION IN NONDESTRUCTIVE EVALUATION SYSTEMS

IITM Technology Available for Licensing

Problem Statement

- Generally, NDE/NDT plays a vital role in improving the manufacturing productivity and quality. There are a few NDT/NDE inspection techniques such as feature-based classification, artificial neural networks & adaptive filtering which have been developed to perform automatic radiographic inspections of the objects.
- However, application of these techniques is restricted due to lack of sufficient training data to train the NDE/NDT system to perform defect identification, which leads to inefficient implementation of said NDT/NDE techniques.
- Present invention addresses above issues in efficient manner.

Technology Category/ Market

Technology: Method for simulation assisted data generation for NDE system;

Industry: NDE/NDT, Artificial Intelligence, Deep learning Industries with Instrumentation fault finding; **Applications:** NDE/NDT Systems.

Market: The global Non-Destructive Testing (NDT) Software Market is projected to grow at a CAGR of **11.10%** during the period (**2024-29**).

Technology

- Present invention describes a system and method for automatically identifying one or more anomalies in the objects.
- The system receives experimental data of the object and applies a probability density function (PDF) upon one or more variables associated with the experimental data to determine corresponding one or more PDF estimates.
- Further generates simulated data associated with the object based on at least one of the one or more PDF estimates and priori data

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associated with the testing of the object.

- The simulated data comprises one or more new anomalies unknown in the experimental data along with the one or more anomalies of the experimental data.
- Furthermore, the system trains a learning model based on the one or more new anomalies and the one or more anomalies of the experimental data.
- The learning model is **applied** for **detecting any anomaly** in an **object**.



Fig.1 shown a network illustrating a system for detecting one or more anomalies in an object;

Intellectual Property

IITM IDF Ref. 1898; IN Patent No. 481776 (Granted)

TRL (Technology Readiness Level)

TRL-4, Proof of Concept ready, tested and validated in Laboratory

Research Lab

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Images

Receive experimental data of the object

Apply a probability density function (PDF) upon one or more

variables associated with the experimental data to determine



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Key Features / Value Proposition

* Technical Perspective:

Efficient Techniques:

claimed invention The enhances the automation of detecting anomalies in an using Non-destructive object а Testing/Evaluation (NDE/NDT).

Using AI Network for generating large & relevant data:

The claimed subject matter further provides techniques for generating large and relevant data for artificial training (such intelligence networks as Deep Learning and/or Machine Learning) for the NDE/NDT system.

Improved Performance:

the claimed patent facilitates improved the accuracy and efficiency of the NDE/NDT system

* Industrial Perspective:

Utility:

Applicable in the industry such as **NDT/NDE** Industry, automation Industry and flaw detection industries, Instrumentation, Oil & gas industries.







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